010					Docket Number (Optional)		Application Number		
INFORMATION DISCLOSURE CITATION					56231-436 (MKS-136) Applicant(s)		10/796,723		
-		(Use several sheets if necess			Shajii, Ali et al.				
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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
RK	A	5,964,653	10/12/99	Perlov et al.		451	288	07/11/97	
	В	6,435,956	08/20/02	Ohwada et al.		451	289	10/02/00	
1/	С	6,277,009	08/21/01	Chen et al.		451	288	01/06/00	
RL	D	6,506,105	01/14/03	Kajiwa	Kajiwara et al.		289	05/12/00	
			10/12/99   Perlov et al.   451   288   07/11/97   289   10/02/00   289   10/02/00   289   10/02/00   289						
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME		SUBCLASS		
. RK	E	US 2002/0142704	10/03/02	Hu et a	Hu et al.		8	03/28/01	
FOREIGN PATENT DOCUMENTS									
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)									
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Form PTO-A820 (also form PTO-1449)